**BOX AF** 

**REPLY UNDER 37 C.F.R. §1.116** EXPEDITED PROCEDURE REQUESTED

## IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:

Jun S. LEE

Conf.:

5244

Serial No.:

09/722,583

Art Unit:

2823

Filed:

November 28, 2000

Examiner: B. Kebede

For:

METHOD FOR FABRICATING CAPACITOR OF

SEMICONDUCTOR DEVICE

## AMENDMENT UNDER 37 C.F.R. §1.116

**Assistant Commissioner for Patents** Washington, DC 20231

September 19, 2002

Sir:

In response to the Office Action mailed July 11 following amendments and remarks are respectfully submitted in connection with the above-identified application:

## IN THE CLAIMS:

Please cancel claims 3 and 6 without prejudice or disclaimer.

Please amend claims 1, 3, 4, and 6 as follows:

1. (Amended) A method for fabricating a capacitor of a semiconductor

device comprising: